

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	Examiner: A. Patel Group Art Unit: 2879	Skun se
TAMAKI KOBAYASHI, ET AL.		dal
Application No.: 09/440,535		8/7/0/
Filed: November 16, 1999		TECH
For: SUBSTRATE FOR ELECTRON) SOURCE, ELECTRON SOURCE : AND IMAGE FORMING) APPARATUS, AND MANU- FACTURING METHOD THEREOF)	July 23, 2001	RECEIVED AUG -3 2001
Commissioner for Patents Washington, D.C. 20221		2800

RESPONSE TO RESTRICTION REQUIREMENT PETITION FOR EXTENSION OF TIME

Sir:

Please extend the time for response to the Office Action of May 22, 2001, to Sunday, July 22, 2001. A check in payment of the \$110.00 fee is enclosed. Please charge any additional fee and credit any overpayment to our Deposit Account 06-1205.

In response to the Office Action dated May 22, 2001, Applicants elect, without traverse, to proceed initially with examination of Group I (Claims 1-22).

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Washington, D.C. 20231

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I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231 (Date of Deposit)

FRANK A. DeLUCIA

of Attorney for Applicant)

Date of Signature

Applicants respectfully request favorable consideration on the merits and early passage to issue of the elected claims.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100 or by facsimile at (212) 218-2200. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Attorney for Applican

Registration No. 477/6

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